Page No.: 1 of: 1

INFORMATION DISCLOSURE		Docket No.: 87	Docket No.: 875.0129.U1(US) Serial No.:				
CITATION FORM FOR			Auglieuss) I agai II-manan				
PATENT APPLICATION (FORM PTO-1449)		Applicant(s): La	Applicant(s): Lassi Hyvonen				
(Substitute)		Filing Date: her	Filing Date: herewith		Group:		
			S. PATENT DOCUMENTS				
Examiner	Document Number	Publication Date	Name of Patentee	or Applicant	Class	Sub-class	
Initials	(Number-Kind Code)	(MM-DD-YYYY)			•		
	US-5,150,046	09-22-1992	Lim		323	356	
	US-5,877,667	03-02-1999	Wollesen		336	200	
	US-6,031,445	02-29-2000	Marty et al.		336	200	
	US-6,580,334 B2	06-17-2003	Simburger et al.		333	24R	
	US-2001/0050607 A1	12-13-2001	Gardner		336	200	
	US-2003/0001713 A1	01-02-2003	Gardner		336	200	
	US-2003/0030534 A1	02-13-2003	Gu et al.		336	221	
	US-2003/0071706 A1	04-17-2003	Christensen		336	200	
	US-		•		•		
	US-						
	US-						
	US-	•	Ì				
	US-						
	US-						
	US-						
	US-		1.				
FOREIGN PATENT DOCUMENTS							
Examiner Initials			Name Of Patentee of Applicant			Translation? Yes/No/n/a	
	. <b></b>						
		•					
					ļ		
		•			. [		
OTHER DOCUMENTS (Author (Capitalize), Title, Date, Pages, Etc., if known)							
"Analytical Modeling and Characterization of Deep-Submicrometer Interconnect", Sylvester, Dennis, Proceedings Of the							
	IEEE, Vol. 89, No. 5, May 2001, pp. 634-664						
· · · · · · · · · · · · · · · · · · ·					· · · · · · · · · · · · · · · · · · ·	<del></del>	
<u> </u>		•				· · · · · · · · · · · · · · · · · · ·	
-							
		· · · · · · · · · · · · · · · · · · ·					

Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered.

Include a copy of this citation form with your next correspondence to the Applicant(s).

Date Considered:

Examiner's Signature: